JUN 1 9 2006 cket No.: P2001,0134

I helpeby certify that this correspondence is being deposited with the United States I be eby certify that this correspondence is being deposited with the Commissioner for Stal Service as First Class Mail in an envelope addressed to the Commissioner for NA 22313-1450 on the date indicated below. Patents, P.O. Box 1450, Alexandria, VA 22313-1450 on the date indicated below.

Date: June 15, 2006

#### ME UNITED STATES PATENT AND TRADEMARK OFFICE

Applic. No.

10/649.411

Confirmation No: 5308

**Applicant** 

Heike Drummer, et. al.

Filed

Aug. 27, 2003

**Art Unit** 

1765

Examiner

Kin Chan Chen

Title

Process for Producing and Removing a Mask Layer

Docket No.

P2001,0134

Customer No.

24131

Date of Notice of Allowance : Mar. 15, 2006

#### LETTER

Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450

Sir:

Please note that the German Priority document number 101 09 328.4 dated February 27, 2001 was filed on October 22, 2003 in the U.S Patent Office. Please find enclosed copies of the following:

- 1) Claim for Priority
- 2) The cover page of priority document; and
- 3) The return postcard indicating receipt by the PTO.

Respectfully submitted.

Reg. No. 41,947

Date: June 15, 2006

Lerner Greenberg Stemer LLP

Post Office Box 2480

Hollywood, FL 33022-2480

Tel:

(954) 925-1100

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/sa

JUN 1 9 2006 By Doroket No.: P2001,0134

Wereby certify that this correspondence is being deposited with the United States Postal Service with sufficient postage as first class mail in an envelope addressed to: Commissioner for Patents, Alexandria, VA 22313 20231.

y: \_\_\_\_\_\_\_

Date: October 22, 2003

#### IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applic. No.

10/649,411

**Applicant** 

Heike Drummer et al.

Filed

August 27, 2003

Art Unit

to be assigned

Examiner

to be assigned

Docket No.

P2001,0134

Customer No.:

24131

## **CLAIM FOR PRIORITY**

Hon. Commissioner for Patents, Alexandria, VA 22313-1450 Sir:

Claim is hereby made for a right of priority under Title 35, U.S. Code, Section 119, based upon the German Patent Application 101 09 328.4 filed February 27, 2001.

A certified copy of the above-mentioned foreign patent application is being submitted herewith.

Respectfully submitted,

GREGORY L. MAYBACK

REG/NO. 40/16

Date: October 22, 2003

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/mjb

# **BUNDESREPUBLIK DEUTSCHLAND**



## Prioritätsbescheinigung über die Einreichung einer Patentanmeldung

Aktenzeichen:

101 09 328.4

Anmeldetag:

27. Februar 2001

Anmelder/Inhaber:

Infineon Technologies AG, München/DE

Bezeichnung:

Verfahren zur Entfernung einer Maskenschicht von

einem Halbleitersubstrat

IPC:

H 01 L 21/3213

Die angehefteten Stücke sind eine richtige und genaue Wiedergabe der ursprünglichen Unterlagen dieser Patentanmeldung.

> München, den 1. Juli 2003 **Deutsches Patent- und Markenamt** Der Präsident

Im Auftrag

**Jero**fsky

S.02/15



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DOCKET NO. P2001,0134 Mailed
APPLIC. NO. 10/649,411 Express Mail
stamp of the Patent Office hereon may be considered the date on which pers indicated below were received.
Applic pgs Rule 53b New Contin Div CIP /Rule 53c Prov. /Rule 53d CPA RCE
□ CIPpgs □ Design □ Dwgs ☑ Declaration ☑ Mailing Certif.
Priority Claim Cert. Prior. Doc(s) PCT Cover Sheet WO
☐ Amend pgs ☐ Prel. Amend pgs É Letter
☐ Response pgs ☐ 37CFR1.116 ☐ Not. of Appeal /
□ Brief pgs □ Appndx pgs □ I.D.S. + Refs. □ 007 2 4 2003
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